



ZFV

Docket No.: 060188-0751

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
Yoshiharu HIDAKA, et al.	:	Confirmation Number: 8259
Application No.: 10/754,518	:	Group Art Unit: 2814
Filed: January 12, 2004	:	Examiner: Thao X. Le

For: SEMICONDUCTOR SUBSTRATE, METHOD FOR FABRICATING THE SAME, AND  
METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

**REQUEST FOR RECONSIDERATION**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 2, 2005, having a three-month shortened statutory period for response set to expire on September 2, 2005, reconsideration of the above-identified application is respectfully requested in view of the following remarks.